



**12500 TI Boulevard, MS 8640, Dallas, Texas 75243**

**PCN# 20120914002**  
**Qualification of RFAB as an additional FAB Site Option for Select TPA2015D1YZH**  
**Devices in the LBC7 Process**  
**Change Notification / Sample Request**

**Date:** 9/19/2012  
**To:** MOUSER PCN

Dear Customer:

This is an announcement of a change to a device that is currently offered by Texas Instruments. The details of this change are on the following pages.

We request you acknowledge receipt of this notification within **30** days of the date of this notice. Lack of acknowledgement of this notice within 30 days constitutes acceptance of the change. If you require samples or additional data to support your evaluation, please request within 30 days.

The changes discussed within this PCN will not take effect any earlier than **90** days from the date of this notification, unless customer agreement has been reached on an earlier implementation of the change. This notification period is per TI's standard process.

This notice does not change the end-of-life status of any product. Should product affected be on a previously issued product withdrawal/discontinuance notice, this notification does not extend the life of that product or change the life time buy offering/discontinuance plan.

For questions regarding this notice, contact your local Field Sales Representative or the PCN Manager ([PCN\\_ww\\_admin\\_team@list.ti.com](mailto:PCN_ww_admin_team@list.ti.com)).

PCN Team  
SC Business Services  
Phone: +1(214) 480-6037  
Fax: +1(214) 480-6659










**20120914002**  
**Attachment: 1**

**Products Affected:**

The devices listed on this page are a subset of the complete list of affected devices. According to our records, these are the devices that you have purchased within the past twenty-four (24) months. The corresponding customer part number is also listed, if available.

<b>DEVICE</b>	<b>CUSTOMER PART NUMBER</b>
TPA2015D1YZHT	null

Technical details of this Product Change follow on the next page(s).

<b>PCN Number:</b>	PCN20120914002			<b>PCN Date:</b>	09/19/2012				
<b>Title:</b>	Qualification of RFAB as an Additional FAB Site Option for Select TPA2015D1YZH Devices in the LBC7 Process								
<b>Customer Contact:</b>	<a href="#">PCN Manager</a>	<b>Phone:</b>	+1(214)480-6037	<b>Dept:</b>	Quality Services				
<b>*Proposed 1<sup>st</sup> Ship Date:</b>	12/19/2012		<b>Estimated Sample Availability:</b>	Date provided at sample request.					
<b>Change Type:</b>									
<input type="checkbox"/>	Assembly Site	<input type="checkbox"/>	Assembly Process	<input type="checkbox"/>	Assembly Materials				
<input type="checkbox"/>	Design	<input type="checkbox"/>	Electrical Specification	<input type="checkbox"/>	Mechanical Specification				
<input type="checkbox"/>	Test Site	<input type="checkbox"/>	Packing/Shipping/Labeling	<input type="checkbox"/>	Test Process				
<input type="checkbox"/>	Wafer Bump Site	<input type="checkbox"/>	Wafer Bump Material	<input type="checkbox"/>	Wafer Bump Process				
<input checked="" type="checkbox"/>	Wafer Fab Site	<input type="checkbox"/>	Wafer Fab Materials	<input type="checkbox"/>	Wafer Fab Process				
<b>PCN Details</b>									
<b>Description of Change:</b>									
This notification is to announce the qualification of RFAB as an additional FAB site option for select TPA2015D1YZH devices in the LBC7 Process.									
Currently Qualified Site, process			<b>Additional Site, Process</b>						
MIHO8, LBC7 Process			<b>RFAB, LBC7 Process</b>						
The LBC7 process was previously qualified at RFAB on 3/3/2011. Qualification details are shown in the Qualification Data Section of this document.									
<b>Reason for Change:</b>									
Continuity of Supply									
<b>Anticipated impact on Form, Fit, Function, Quality or Reliability (positive / negative):</b>									
None									
<b>Changes to product identification resulting from this PCN:</b>									
Chip Site:									
<b>Current</b>									
Chip Site	Chip site code (20L)	Chip country code (21L)							
MIHO8	MH8	JPN							
<b>New</b>									
Chip Site	Chip site code (20L)	Chip country code (21L)							
<b>RFAB</b>	<b>RFB</b>	<b>USA</b>							
Sample product shipping label (not actual product label)									
<table border="1"> <tr> <td>  <b>TEXAS INSTRUMENTS</b>  MADE IN: Malaysia  2DC: 2d:  MSL 2 /260C/1 YEAR SEAL DT  MSL 1 /235C/UNLIM 03/29/04  OPT:  ITEM: 39  <b>LBL: 5A (L)T0:1750</b> </td> <td>   <b>G4</b> </td> <td>  </td> <td> (1P) <b>SN74LS07NSR</b>  (Q) <b>2000</b> (D) <b>0336</b>  (31T) LOT: 3959047MLA  (4W) TKY (1T) 7523483S12  (P)  (2P) REV: (V) 0033317  (20L) <b>CS0: SHE</b> (21L) <b>CC0:USA</b>  (22L) AS0:MLA (23L) AC0:MYS </td> </tr> </table>						 <b>TEXAS INSTRUMENTS</b> MADE IN: Malaysia 2DC: 2d: MSL 2 /260C/1 YEAR SEAL DT MSL 1 /235C/UNLIM 03/29/04 OPT: ITEM: 39 <b>LBL: 5A (L)T0:1750</b>	 <b>G4</b>		(1P) <b>SN74LS07NSR</b> (Q) <b>2000</b> (D) <b>0336</b> (31T) LOT: 3959047MLA (4W) TKY (1T) 7523483S12 (P) (2P) REV: (V) 0033317 (20L) <b>CS0: SHE</b> (21L) <b>CC0:USA</b> (22L) AS0:MLA (23L) AC0:MYS
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<b>Product Affected:</b>					
HPA01080YZHR		TPA2015D1YZHR		TPA2015D1YZHT	
<b>Qualification Data: Approval Date 3/3/2011</b>					
This qualification has been developed for the validation of this change. The qualification data will validate that the proposed change meets the applicable released technical specifications.					
<b>Qual Vehicle 1: TPIC2020RTQRG4</b>					
Wafer Fab Site:		RFAB	Metallization:		200Ti / 275TiN / 4500AlCu / 50Ti /300TiN
Wafer Fab Process:		LBC7	Wafer diameter:		300mm
<b>Qualification:</b> <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results					
Reliability Test		Conditions		Sample Size Lot#1   Lot#2   Lot#3	
Life Test		1000/125C/Vmax		80/0	80/0    80/0
**Biased HAST		96/130C/85%/Vmax		80/0	-       -
**Autoclave 121C		96/121C/2 atm		80/0	-       -
**Temperature Cycle		1000/-65/150C		80/0	80/0    80/0
**High Temp. Storage Bake		150C (1000 Hrs)		80/0	-       -
ESD HBM		2000V		27/0	27/0    27/0
ESD CDM		750V		3/0	3/0       3/0
**Thermal Path Integrity		Per appropriate package level		12/0	12/0    12/0
Latch-up		(per JESD78)		6/0	6/0       6/0
** Preconditioning sequence: level 3 @ 260C peak +5/-0C					
<b>Qual Vehicle 2: TPS65830YFFR</b>					
Wafer Fab Site:		RFAB	Metallization:		200Ti / 275TiN / 4500AlCu / 50Ti /300TiN
Wafer Fab Process:		LBC7	Wafer diameter:		300mm
<b>Qualification:</b> <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results					
Reliability Test		Conditions		Sample Size Lot#1   Lot#2   Lot#3	
**Unbiased HAST 130C/85%RH		96/-		38/0	38/0    38/0
**Temperature Cycle		-55/125C 1000 Cycles		39/0	38/0    37/0
ESD HBM		2000V		1/0	1/0       1/0
ESD CDM		500V		1/0	1/0       1/0
Latch-up		(per JESD78)		3/0	3/0       3/0
** Preconditioning sequence: level 1 @ 260C peak +5/-0C					
<b>Qual Vehicle 3: TPS65170RHDR</b>					
Wafer Fab Site:		RFAB	Metallization:		200Ti / 275TiN / 4500AlCu / 50Ti /300TiN
Wafer Fab Process:		LBC7	Wafer diameter:		300mm

Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results					
Reliability Test		Conditions	Sample Size		
			Lot#1	Lot#2	Lot#3
**Autoclave 121C		96/121C	38/0	38/0	38/0
**Temperature Cycle		-65/150C 1000 Cycles	39/0	39/0	39/0
**Thermal Shock		-65/150C 1000 Cycles	38/0	38/0	38/0
ESD HBM		2000V	3/0	3/0	3/0
ESD CDM		750V	3/0	3/0	3/0
Moisture Sensitivity, L2		Visual-1/40X	12/0	-	-
Moisture Sensitivity, L2		CSAM-1/100%	12/0	-	-
Moisture Sensitivity, L2		ThruSAM-1/100%	12/0	-	-
Moisture Sensitivity, L2		24/125C	12/0	-	-
Moisture Sensitivity, L2		168/85C / 60%	12/0	-	-
Moisture Sensitivity, L2		3/260C +5 / -0C	12/0	-	-
Moisture Sensitivity, L2		Visual-2/40X	12/0	-	-
Moisture Sensitivity, L2		Elec/25C	12/0	-	-
Moisture Sensitivity, L2		CSAM-2/100%	12/0	-	-
Moisture Sensitivity, L2		ThruSAM-2/100%	12/0	-	-
** Preconditioning sequence: level 3 @ 260C peak +5/-0C					
Qual Vehicle 4: TLS2602DCARG4					
Wafer Fab Site:		RFAB	Metallization: 200Ti / 275TiN / 4500AlCu / 50Ti /300TiN		
Wafer Fab Process:		LBC7	Wafer diameter: 300mm		
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results					
Reliability Test		Conditions	Sample Size		
			Lot#1	Lot#2	Lot#3
Life Test, 125C		1000/125C Vmax	80/0	80/0	80/0
**Autoclave 121C		96/121C/2atm	80/0	-	-
**Temperature Cycle		-65/150C 1000 Cycles	39/0	39/0	39/0
ESD HBM		2000V	3/0	3/0	3/0
ESD CDM		750V	3/0	3/0	3/0
**Thermal Path Integrity, L3-260C		PRE VM	12/0	-	-
**Thermal Path Integrity, L3-260C		PRE SAM/CSAM/TSAM	12/0	-	-
**Thermal Path Integrity, L3-260C		Bake 24hr/125C	12/0	-	-
**Thermal Path Integrity, L3-260C		Soak 192hr/30C/60%	12/0	-	-
**Thermal Path Integrity, L3-260C		Reflow x3/260C +5/-0	12/0	-	-
**Thermal Path Integrity, L3-260C		POST VM	12/0	-	-
**Thermal Path Integrity, L3-260C		DC TEST	12/0	-	-
**Thermal Path Integrity, L3-260C		POST SAM/CSAM/TSAM	12/0	-	-
**Thermal Path Integrity, L3-260C		T/C 500cy/-65C/150C	12/0	-	-
**Thermal Path Integrity, L3-260C		POST TC SAM/CSAM/TSAM	12/0	-	-
Latch-up		CI/100mA	6/0	6/0	6/0
Latch-up		OV/1.5Vmax	6/0	6/0	6/0
** Preconditioning sequence: level 3 @ 260C peak +5/-0C					

Qual Vehicle 5: TPS62620YFFR					
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN		
Wafer Fab Process:	LBC7	Wafer diameter:	300mm		
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results					
Reliability Test		Conditions	Sample Size		
			Lot#1	Lot#2	Lot#3
Temperature Cycle		-55/125C 1000 Cycles	80/0	80/0	80/0
ESD HBM		2000V	3/0	3/0	3/0
ESD CDM		750V	3/0	3/0	3/0
Signal Latch-up		before/85C	6/0	6/0	6/0
Signal Latch-up		after/85C	6/0	6/0	6/0
Qual Vehicle 6: TPA6140A2YFFR					
Wafer Fab Site:	RFAB	Metallization:	200Ti / 275TiN / 4500AlCu / 50Ti /300TiN		
Wafer Fab Process:	LBC7	Wafer diameter:	300mm		
Qualification: <input type="checkbox"/> Plan <input checked="" type="checkbox"/> Test Results					
Reliability Test		Conditions	Sample Size		
			Lot#1	Lot#2	Lot#3
L/T 140C		480/-	38/0	39/0	40/0
**Unbiased HAST 130C/85%RH		96/-	39/0	39/0	39/0
**Temperature Cycle		-55/125C, 1000V	3/0	3/0	3/0
ESD HBM		2000V	3/0	3/0	3/0
ESD CDM		750V	3/0	3/0	3/0
Latch-up		Latchup	6/0	6/0	6/0
Latch-up		Elec Test	6/0	6/0	6/0
** Preconditioning sequence: level 3 @ 260C peak +5/-0C					

For questions regarding this notice, e-mails can be sent to the regional contacts shown below, or you can contact your local Field Sales Representative.

Location	E-Mail
USA	<a href="mailto:PCNAmericasContact@list.ti.com">PCNAmericasContact@list.ti.com</a>
Europe	<a href="mailto:PCNEuropeContact@list.ti.com">PCNEuropeContact@list.ti.com</a>
Asia Pacific	<a href="mailto:PCNAsiaContact@list.ti.com">PCNAsiaContact@list.ti.com</a>
Japan	<a href="mailto:PCNJapanContact@list.ti.com">PCNJapanContact@list.ti.com</a>